

Application/Control No.	Applicant(s)/Patent under Reexamination	
09/974,885	LEE, JEN-FU	
Examiner	Art Unit	
Linda Krisciunas	3623	

SEARCHED							
Class	Subclass	Date	Examiner				
705	7	2/28/2006	LMK				
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
East search (see attached)	2/28/2006	LMK	
Dialog search (see attached)	2/28/2006	LMK	
related case search	3/1/2006	LMK	